

SEARCHED

Class	Sub.	Date	Exmr.
250	492.2	06/28/02	BES
"	492.21		
280	281-284		
"	288, 288A	06/18/02	BES
"	294, 295		
"	297, 298		
"	423R		
315	111.81	06/18/02	
"	541		
"	505		
324	466, 459	06/18/02	BES
	464		
Updated		04/28/03	BES

INTERFERENCE SEARCHED

Class	Sub.	Date	Exmr.
250	398		
	492.21		
	492.2		
	492.3		
"	492.1		
438	14		
	514		
	516		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)

WEST Key word search (ion implant) + (energy source minimization) + transport efficiency (ion implant or LINK or linear accel- erator) + (measure beam energy)	Date	Exmr.
	06/21/02	BES
	06/24/02	BES
Updated	04/28/03	BES